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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Multiple sheets used when necessary) SHEET 1 OF 1

	PTO/SB/08 Equivalent
Application No.	10/582,588
Filing Date	June 9, 2006
First Named Inventor	Williams et al.
Art Unit	Unknown 2827
Examiner	Unknown C.Y.
Attorney Docket No.	DAVI258.003APC

	U.S. PATENT DOCUMENTS					
	Examiner Initials	Cite No.	Document Number Number - Kind Code (if known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
ĺ		1	4,586,164	04-29-1986	Eden Dayton D	

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	2	JP 60 180886	09-14-1985	Fujitsu Ltd.		

NON PATENT LITERATURE DOCUMENTS				
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	3	KAILER A. et al., "Phase transformations of silicon caused by contact loading" © 1997 American Institutes of Physics: J Appl. Phys. Vol. 81, No. 7,1 April 1997, pgs 3057-3063		
	4	Suppl. European Search Report, EP 04 80 2037, Date: 6/28/2007.		

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Examiner Signature /Connie Yoha/ Date Considered 02/15/2010

*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if